TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of	
Invention	

[INTERCONNECT PROCESS AND METHOD FOR REMOVING METAL SILICIDE]

Application Number:

Date:

First Named Applicant:

Mr. Tien-Sung Chen

Confirmation Number:

Attorney Docket Number:

11004-US-PA

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Submitted By:	Elec. Sign.	Sign. Capacity
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Registered Number: 46,863		

Documents being submitted:	Files
us-assignment	11004-usassn.xml
	us-assignment.xsl
	us-assignment.dtd
	11004assignment01.tif
	11004assignment02.tif
us-request	11004-usrequ.xml
	us-request.dtd
	us-request.xsl
us-fee-sheet	11004-usfees.xml
	us-fee-sheet.xsl
	us-fee-sheet.dtd
application-body	11004-trans.xml
	us-application-body.xsl
	application-body.dtd
	wipo.ent
	mathml2.dtd
	mathml2-qname-1.mod
	isoamsa.ent
	isoamsb.ent
	isoamsc.ent
	isoamsn.ent
	isoamso.ent
	isoamsr.ent
	isogrk3.ent
	isomfrk.ent
	isomopf.ent
	isomscr.ent
	isotech.ent
	isobox.ent
	isocyr1.ent
	isocyr2.ent
	isodia.ent
	isolat1.ent
	isolat2.ent
	isonum.ent
	isopub.ent
	mmlextra.ent
	mmlalias.ent
	soextblx.dtd
	11004us0001.tif
	11004us0002.tif
	11004us0003.tif
us-declaration	11004declaration01.tif
us-declaration	11004declaration02.tif

Comments

Please be kindly advised that the indicated fees of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 11004-US-PA), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw